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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Shigeo ASHIGAKI, et al.

Confirmation No. 9535

U.S. Serial No.: 10/591,345

Group Art Unit: 1795

Filed: August 31, 2006

Examiner: Ponder N. Thompson Rummel

For: PEELING-OFF METHOD AND REWORKING METHOD OF RESIST FILM

SEVENTH INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449) which lists the document noted in a Chinese Office Action issued on August 1, 2008 for Chinese Application No. 200580006516.6.


It is respectfully requested that the cited document be considered by the Examiner in the above-identified patent application, that it be made officially of record therein and that a listing of same appear on the face of any patent which may issue in this application.

An Official Action on the merits has issued for this application. In accordance with the requirements of 37 C.F.R. §1.97(d), Applicants include a check for \$180 in payment of the requisite fee (37 C.F.R §1.17(p)).

Respectfully submitted,

SMITH, GAMBRELL & RUSSELL, LLP

By:


Michael A. Makuch, Reg. No. 32,263
1130 Connecticut Avenue, Suite 1130
Washington, D.C. 20036
Telephone: (202) 263-4300
Fax: (202) 263-4329

December 9, 2008

12/10/2008 SZEWDIE1 00000038 10591345

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